

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Klaus Leitner  
Application No. : 10/525,993  
Filing Date : February 28, 2005  
For : SPUTTERING CATHODE, PRODUCTION METHOD AND  
CORRESPONDING CATHODE  
Examiner : Jason Berman  
Art Unit : 1795  
Confirmation No. : 2830

**6 Pages**  
**Via EFS**  
**Mail Stop Amendment**  
**Attn: Examiner Stigell**  
**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, Virginia 22313-1450**

**ELECTION**

Sir:

In response to the restriction requirement dated July 17, 2008, please take note of  
the following.